PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1 Stylesheet Version v1.2 EPAS ID: PAT3924469

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
AIXTRON, INC.	05/17/2016

RECEIVING PARTY DATA

Name:	AIXTRON SE
Street Address:	DORNKAULSTR. 2
City:	HERZOGENRATH
State/Country:	GERMANY
Postal Code:	52134

PROPERTY NUMBERS Total: 10

Property Type	Number
Application Number:	12832947
Application Number:	12832953
Application Number:	13921969
Application Number:	14321233
Application Number:	14735048
Patent Number:	8697197
Patent Number:	8765232
Patent Number:	9299956
Patent Number:	9096932
Patent Number:	9096933

CORRESPONDENCE DATA

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ATTORNEY DOCKET NUMBER: 2001

PATENT REEL: 038947 FRAME: 0139

NAME OF SUBMITTER:	TAREK N. FAHMI		
SIGNATURE:	/Tarek N. Fahmi/		
DATE SIGNED:	06/17/2016		
Total Attachments: 2			
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source=Aixtron Inc Assign to Aixtron SF#page2 tif			

PATENT REEL: 038947 FRAME: 0140

ASSIGNMENT

This Assignment (this "Assignment") is made as of MAY 17, 2016 by Aixtron Inc., a California corporation having an address at 1139 Karlstad Dr., Sunnyvale, CA 94089 ("Assignor"), to Aixtron SE, a Societas Buropaea having an address at Domkaulstr. 2, Herzogenrath, Germany 52134 ("Assignee").

RECITALS

- Assignor is the owner of the United States Patents and patent applications set forth on Exhibit A hereto (the "Patents").
- B. Assignor now desires to assign to Assignee all of Assignor's right, title and interest in and to the Patents and Assignee desired to receive said assignment,

AGREEMENT

NOW, THEREFORE, in consideration of the foregoing premises, and the covenants and agreements in this Assignment, Assignor and Assignee agree as follows:

- 1. Assignor does hereby sell, transfer, convey, assign and deliver to Assignee all of Assignor's right, title and interest in and to the Patents, including any foreign counterparts, divisions, continuations or reissues thereof, the same to be held by Assignee for Assignee's own use and enjoyment, and for the use and enjoyment of Assignee's successors, assigns and other legal representatives, as fully and entirely as the same would have been held and enjoyed by Assignor if this Assignment and sale had not been made; together with all claims for damages by reason of past infringements of the Patents, along with the right to sue for and collect such damages for the use and benefit of Assignee and its successors, assigns and other legal representatives.
- Assignor hereby authorizes and requests the Commissioner for Patents of the United States, and any officer of any country or countries foreign to the United States, whose duty it is to issue patents or other evidence or forms of intellectual property protection or applications as aforesaid, to issue the same to Assignee and its successors, assigns and other legal representatives in accordance with the terms of this instrument.

IN WITNESS WHEREOF, the parties have executed this Assignment on the date first above written.

- Vilh

Name: Dr. Bernd Schulle

Title: Director of the Board

Assignee Aftron SE

Name: Martir Goetzeler Dr. Gernd Schulte

Title: President & CEO Executive Vice President, COO

PATENT REEL: 038947 FRAME: 0141

EXHIBIT A

TO PATENT ASSIGNMENT

Description	Patent / Patent Application Number	Issue / Filing Date
METHODS FOR PLASMA PROCESSING	8,697,197	04-15-2014
APPARATUS AND METHOD FOR DIELECTRIC DEPOSITION	8,765,232	07-01-2014
PLASMA GENERATING UNITS FOR PROCESSING A SUBSTRATE	12/832,947	07-08-2010
APPARATUS FOR PLASMA PROCESSING	12/832,953	07-08-2010
METHOD FOR DEPOSITION OF HIGH- PERFORMANCE COATINGS AND ENCAPSULATED ELECTRONIC DEVICES	9,299,956	03-29-2016
APPARATUS AND METHOD FOR FORMING THIN PROTECTIVE AND OPTICAL LAYERS ON SUBSTRATES	13/921,969	06-19-2013
METHODS FOR PLASMA PROCESSING	9,096,932	08-04-2015
METHODS FOR PLASMA PROCESSING	9,096,933	08-04-2015
APPARATUS AND METHOD FOR DIELECTRIC DEPOSITION	14/321,233	07-01-2014
METHOD FOR PLASMA PROCESSING	14/735,048	06-10-2015

RECORDED: 06/17/2016 REEL: 038947 FRAME: 0142